



Docket No.: 146712016100  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Chang Bok YI

Application No.: 10/674,946

Confirmation No.: 5267

Filed: September 29, 2003

Art Unit: 1773

For: SYSTEM AND METHOD FOR IDENTIFYING  
SUBSTRATE SIDE

Examiner: H. C. Rickman

**RESPONSE TO RESTRICTION REQUIREMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed August 22, 2005. Applicant hereby provisionally elects claims 12-17 for continued examination.

The Examiner has required restriction between Group I – Claims 1-17, drawn to a substrate holder for a deposition process and a film deposition system and Group II – Claims 12-17, drawn to a disk.

In the unlikely event that the transmittal form is separated from this document and the Patent Office determines that an extension and/or other relief is required, Applicant petitions for any required relief including extensions of time and authorize the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to **Deposit Account No. 03-1952** referencing **146712016100**. However, the Commissioner is not authorized to charge the cost of the issue fee to the Deposit Account.

Dated: November 22, 2005

Respectfully submitted,

By 

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